

Docket No.: 59516-052

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Zi-Kui LIU, et al.	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: February 24, 2004	:	Examiner:
	:	
For: BORIDE THIN FILMS ON SILICON	:	

**CLAIM OF PRIORITY**

Mail Stop CPD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**U.S. Provisional Application No. 60/450,321, filed February 28, 2003.**

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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**Date: February 24, 2004**